## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

re the Application of: Shun-ichi FUKUYAMA et al.

Group Art Unit: 2813

Serial No.: 10/630,716 Examiner: Stephen W. Smoot

Filed: July 31, 2003 Confirmation No.: 9374

For: SEMICONDUCTOR DEVICE USING LOW-K MATERIAL AS

INTERLAYER INSULATING FILM AND ITS MANUFACTURE

**METHOD** 

Attorney Docket Number: 030860

Customer Number: 38834

## **AMENDMENT TRANSMITTAL**

Commissioner for Patents P. O. Box 1450 Alexandria, VA 22313-1450

Date: April 20, 2005

Sir:

Transmitted herewith is an Amendment in the above-identified application. The fee has been calculated as shown below.

	CLAIMS REMAINING AFTER AMENDMENT		HIGHEST NUMBER PREVIOUSLY PAID FOR		SENT
Total (37 CFR 1.16(c))	8	Minus	20	=	0
Independent (37 CFR 1.16(b))	4	Minus	3	=	1
FIRST PRESENT.	ATION OF MULTIF	PLE DEPE	NDENT CLAIM (37	CFR 1.	.16(d))

SMALL ENTITY		OR	OTHER THAN SMALL ENTITY	
RATE	ADDI- TIONAL FEE		RATE	ADDI- TIONAL FEE
X \$25		OR	X\$50	.00
X \$100		OR	X\$200	200.00
+ \$180		OR	+ \$360	.00
TOTAL ADD'L FEE		А	TOTAL DD'L FEE	200.00

XX Enclosed please find our check in the amount of \$200.00.00 for the additional claims fee in connection with this Amendment.

The Commissioner is hereby authorized to charge payment for any additional fees associated with this communication or credit any overpayment to Deposit Account No. 50-2866.

Respectfully submitted,

WESTERMAN, HATTORI, DANIELS & ADRIAN, LLP

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